	Application No.	Applicant(s)	
Supplemental Notice of Allowability	10/817,555	VAUGHAN ET AL.	`
	Examiner	Art Unit	
	Dahada Débasa	4740	
	Roberto Rábago	1713	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not includ will be mailed in due	ed course. THIS
1. This communication is responsive to			
2. The allowed claim(s) is/are 1-10,13 and 15.			
 3. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 			
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3. Copies of the certified copies of the priority doc	• • • • • • • • • • • • • • • • • • • •		ition from the
International Bureau (PCT Rule 17.2(a)).	same nave been received in the	iational otago applioc	
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the re	quirements
 A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give 			IOTICE OF
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.		
(a) including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-9	948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the O	ffice action of	
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the			e back) of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I 			Note the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal Pa	atent Application (PT	O ₋ 152\
Notice of Preferences Cited (1 10-092) Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary		0-102)
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Dat	ė	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's Stateme	nt of Reasons for Allo	owance
or brological Material	• 9. 🗌 Other		

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Leandro Arechederra on 8/22/2006.

In the claims:

1. (currently amended) A process for polymerizing olefin(s) to produce a polymer product, the process comprising contacting ethylene and at least one comonomer with a catalyst system, wherein the catalyst system comprises a poor comonomer incorporating catalyst compound comprising a metallocene structure comprising at least one fused ring cyclopentadienyl ligand bridged to another cyclopentadienyl ligand, where the bridge is a long bridge defined as a bridge containing 2-or more atoms an Si-O-Si group, and a good comonomer incorporating metallocene catalyst compound; wherein the poor incorporator is a polymerization catalyst which when run under process conditions wherein (Ind)₂ZrCl₂ would produce a 0.920 g/cm³ density polyethylene, produces a polymer with a density greater than 0.920 g/cm³; further comprising isolating a polymer product having a density of from 0.910 to 0.940 g/cm³, an Mw/Mn value of from 2 to less than 10 and an l₂ value of from 0.1 to 100 dg/min.

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Reasons for Allowance

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2. The following is an examiner's statement of reasons for allowance. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Newly cited is Chien (US 6,177,377) which discloses in Example 55 a method of making an in-situ blend of polyethylene and ethylene copolymer comprising a poor comonomer incorporating metallocene compound having a four-atom bridge and a second metallocene. However, the reference does not disclose analogous methods comprising a fused-ring metallocene comprising a bridge with an Si-O-Si group as currently amended; no motivation can be found to modify the reference example to use the type of metallocene specified in the claims.

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Roberto Rábago whose telephone number is (571) 272-1109. The examiner can normally be reached on Monday - Friday from 8:00 - 4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Wu can be reached on (571) 272-1114. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Roberto Rábago

Primary Examiner
Art Unit 1713

RR August 22, 2006

> DAVID W. WU SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 1700